

PATENT ASSIGNMENT COVER SHEET

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EPAS ID: PAT2971153

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
FRANCOIS HEBERT	07/17/2014
I-SHAN SUN	07/22/2014
YOUNG BAE KIM	07/16/2014
YOUNG JU KIM	07/16/2014
KWANG IL KIM	07/16/2014
IN TAEK OH	07/16/2014
JIN WOO MOON	07/16/2014
RECEIVING PARTY DATA	
Name:	MAGNACHIP SEMICONDUCTOR, LTD.
Street Address:	215, DAESIN-RO, HEUNGDEOK-GU, CHEONGJU-SI, CHUNGCHEONGBOK-DO 361-725
City:	CHEONGJU-SI
State/Country:	KOREA, REPUBLIC OF
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	14453246
CORRESPONDENCE DATA	
Fax Number:	(202)315-3758
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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Correspondent Name:	NSIP LAW
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ATTORNEY DOCKET NUMBER:	023103.0120
NAME OF SUBMITTER:	RANDALL S. SVIHLA
SIGNATURE:	/Randall S. Svihla/
DATE SIGNED:	08/06/2014
Total Attachments: 6	

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COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

DECLARATION

As a below-named inventor, I hereby declare that this declaration is directed to the application attached hereto, or to United States Application Number or PCT International Application Number

_____ filed on _____ (if applicable), entitled:

METHOD OF FABRICATING SEMICONDUCTOR DEVICE

The above-identified application was made or authorized to be made by me.

I believe I am the original inventor or an original joint inventor of a claimed invention in the above-identified application.

I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 USC 1001 by fine or imprisonment of not more than five (5) years, or both.

I have reviewed and understand the contents of the above-identified application, including the claims.

I am aware of the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information that became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

ASSIGNMENT

For valuable consideration, I, as a below-named assignor, hereby assign to:

MagnaChip Semiconductor, Ltd.
215, Daesin-ro, Heungdeok-gu
Cheongju-si, Chungcheongbuk-do 361-725
Republic of Korea

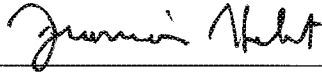
and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title, and interest throughout the world in the inventions and improvements that are the subject of the application identified in the above declaration, which is United States Application Number or PCT International Application Number 14/453,246 filed on August 6, 2014

I authorize and request the attorneys appointed in the above-identified application to hereafter complete this Assignment by inserting above the application number and the filing date of the above-identified application when known, and to correct any typographical errors that may be discovered in this Assignment.

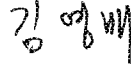
This Assignment includes the above-identified application, any and all United States and foreign patents, utility models, and design registrations granted for any of the inventions and improvements that are the subject of the above-identified application, and the right to claim priority based on the filing date of the above-identified application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and I authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, design registrations, like rights of exclusion, and inventors' certificates for any of the inventions and improvements that are the subject of the above-identified application; and I agree for myself and my heirs, legal representatives, and assigns without further compensation to perform such lawful acts and to sign such further applications, Assignments, preliminary statements, and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment.

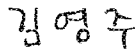
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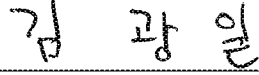
In witness whereof, I, as a below-named inventor and assignor, intending to be legally bound, have hereunto affixed my signature on the date indicated below next to my signature.

Inventor's Legal Name	Francois HEBERT		
Inventor's Signature		Date	2014-July, 17
Residence (City, Country)	San Mateo, CA, USA		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

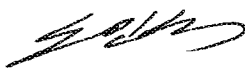
Inventor's Legal Name	I-Shan SUN		
Inventor's Signature		Date	
Residence (City, Country)	San Jose, CA, USA		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

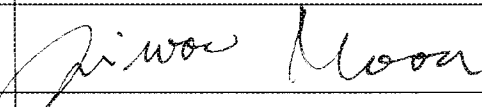
Inventor's Legal Name	Young Bae KIM		
Inventor's Signature		Date	2014. 7. 16
Residence (City, Country)	Cheongju-si, Republic of Korea		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	Young Ju KIM		
Inventor's Signature		Date	2014. 7. 16
Residence (City, Country)	Cheongju-si, Republic of Korea		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	Kwang Il KIM		
Inventor's Signature		Date	2014. 7. 16
Residence (City, Country)	Cheongju-si, Republic of Korea		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

Inventor's Legal Name	In Taek OH		
Inventor's Signature		Date	2014. 7. 16
Residence (City, Country)	Cheongju-si, Republic of Korea		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	Jin Woo MOON		
Inventor's Signature		Date	2014. 7. 16
Residence (City, Country)	Cheongju-si, Republic of Korea		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

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I believe I am the original inventor or an original joint inventor of a claimed invention in the above-identified application.

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I have reviewed and understand the contents of the above-identified application, including the claims.

I am aware of the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information that became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

ASSIGNMENT

For valuable consideration, I, as a below-named assignor, hereby assign to:

MagnaChip Semiconductor, Ltd.
215, Daesin-ro, Heungdeok-gu
Cheongju-si, Chungcheongbuk-do 361-725
Republic of Korea

and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title, and interest throughout the world in the inventions and improvements that are the subject of the application identified in the above declaration, which is United States Application Number or PCT International Application Number

14/453,246 filed on August 6, 2014.

I authorize and request the attorneys appointed in the above-identified application to hereafter complete this Assignment by inserting above the application number and the filing date of the above-identified application when known, and to correct any typographical errors that may be discovered in this Assignment.


This Assignment includes the above-identified application, any and all United States and foreign patents, utility models, and design registrations granted for any of the inventions and improvements that are the subject of the above-identified application, and the right to claim priority based on the filing date of the above-identified application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and I authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, design registrations, like rights of exclusion, and inventors' certificates for any of the inventions and improvements that are the subject of the above-identified application; and I agree for myself and my heirs, legal representatives, and assigns without further

COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

compensation to perform such lawful acts and to sign such further applications, Assignments, preliminary statements, and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment.

In witness whereof, I, as a below-named inventor and assignor, intending to be legally bound, have hereunto affixed my signature on the date indicated below next to my signature.

Inventor's Legal Name	Francois HEBERT		
Inventor's Signature		Date	
Residence (City, Country)	San Mateo, CA, USA		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	I-Shan SUN		
Inventor's Signature		Date	7/22/2014
Residence (City, Country)	San Jose, CA, USA		
Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	Young Bae KIM		
Inventor's Signature		Date	
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Inventor's Legal Name	Young Ju KIM		
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Inventor's Legal Name	Kwang Il KIM		
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Mailing Address	c/o MagnaChip Semiconductor, Ltd., 215, Daesin-ro, Heungdeok-gu, Cheongju-si, Chungcheongbuk-do 361-725, Republic of Korea		

Inventor's Legal Name	In Taek OH		
Inventor's Signature		Date	
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